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520.30414R5<u>1</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

S. KATO, et al.

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Serial No:

10/066,747

FEB 0 9 2004

Filed:

February 6, 2002

TECHNOLOGY CENTER R3700

Title:

VACUUM PROCESSING APPARATUS AND OPERATING

METHOD THEREFOR

Group:

3749

Examiner:

Pamela Anne WILSON

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TECHNOLOGY CENTER R3700

<u>RESPONSE</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

February 3, 2004

Sir:

In response to the Office Action mailed October 3, 2003, Applicants respectfully submit the following remarks, and also submit the following listed documents:

- (1) Official Letters Patent for U.S. Patent No. 6,330,755;
- (2) Consent of Assignee, for filing the above-identified reissue application;
 - (3) Statement Under 37 C.F.R. §3.73(b); and
- (4) Supplemental Reissue Application Declaration and Power of Attorney by Inventor.

Furthermore, noting the comments by the Examiner concerning the Information Disclosure Statement filed September 23, 2002, also enclosed herewith is a Supplementing Information Disclosure Statement, with respect